



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

February 24, 2025

IGI Report Number

LG674560139

Description

LABORATORY GROWN DIAMOND

Shape and Cutting Style

MODIFIED OCTAGON STEP CUT

Measurements

8.85 X 8.69 X 3.10 MM

GRADING RESULTS

Carat Weight

2.19 CARATS

Color Grade

G

Clarity Grade

VVS 2

ADDITIONAL GRADING INFORMATION

Polish

EXCELLENT

Symmetry

EXCELLENT

Fluorescence

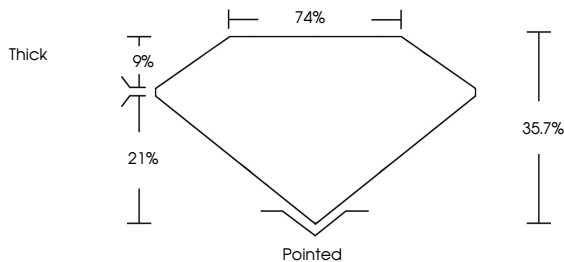
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Inscription(s)

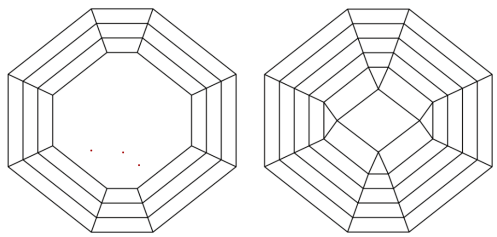
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Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

D E F G H I J Faint Very Light Light

CLARITY

IF VVS ¹⁻² VS ¹⁻² SI ¹⁻² I ¹⁻³

Internally Flawless Very Very Slightly Included Very Slightly Included Slightly Included Included

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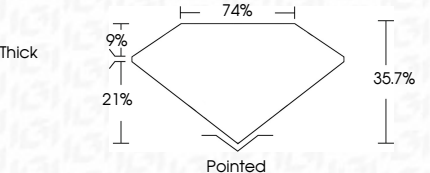
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February 24, 2025

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MODIFIED OCTAGON STEP CUT

8.85 X 8.69 X 3.10 MM

2.19 CARATS

G

VVS 2

85.7%

74%

Thick

Pointed

EXCELLENT

EXCELLENT

NONE

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